



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of
Gerhard SCHNEIDER et al.

Atty. Docket No.:
5196/ETCH/CONE/JB1

Appln. No.: 09/834,501

Group Art Unit: 1763

Filed: Apr. 12, 2001

Examiner: L. Alejandro
Mulero

Conf. No.: 5799

Title: MUSHROOM STEM WAFER
PEDESTAL FOR IMPROVED
CONDUCTANCE AND UNIFORMITY

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AMENDMENT UNDER 37 C.F.R. § 1.111
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Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

In reply to the Office Action mailed August 20, 2002, the period for reply having been extended by petition to February 20, 2003, please amend the above-identified patent application as follows:

IN THE CLAIMS:

Cancel claims 1-11.

Amend claims 12-15 so that claims 12-19 read as follows:

12. (Once Amended) A processing system for simultaneously processing two semiconductor articles under substantially identical process conditions, the processing system comprising:
a chamber body having a bottom wall with a pumping port